



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Yasunori, et al.

Attorney Docket No.: MURTP083D1

Application No.: 10/640,850

Examiner: To Be Assigned

Filed: August 13, 2003

Group: 1755

Title: METHOD OF PRODUCING CERAMIC  
THERMISTOR CHIPS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Alexandria, Virginia 22313-1450 on May 25, 2005.

Signed: 

Deborah Neill

**INFORMATION DISCLOSURE STATEMENT**  
**37 CFR §§1.56 AND 1.97(b)**

Commissioner for Patents  
Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449 may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. MURTP083D1).

Respectfully submitted,

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<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	Atty Docket No. <b>MURTP083D1</b>	Application No.: <b>10/640,850</b>
	Applicant: <b>Yasunori Ito, et al.</b>	
	Filing Date <b>August 13, 2003</b>	Group <b>1755</b>

#### U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A	2,253,376	08/19/41	Johnson			06/25/39
	B	3,813,296	05/28/74	McStrack, et al.			11/23/72
	C	4,912,450	03/27/90	Yoneda, et al.			08/25/88
	D	4,993,142	02/19/91	Burke, et al.			06/19/89
	E	5,300,760	04/05/94	Batliwalla, et al.			01/21/92
	F	5,534,843	07/09/96	Tsunoda, et al.			01/28/94
	G	5,629,666	05/13/97	Imai, et al.			05/22/95

#### Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	H	3-504551	10/03/91	Japan				
	I	8-321405	12/03/96	Japan				
	J	4064201	2/1992	Japan				
	K	8-124720	5/1996	Japan				
	L	9-260106	10/1997	Japan				

#### Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	M	Singer, et al., <i>Industrial Ceramics</i> , pp 1199-1200 (1963).
	N	
	O	
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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	Applicant:	
	<b>Yasunori Ito, et al.</b>	
Filing Date	Group	
<b>August 13, 2003</b>	<b>1755</b>	

### U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	P	5,637,543	06/10/97	Iwaya, et al.			12/18/95
	Q	5,644,284	07/01/97	Moriwake, et al.			04/25/95
	R	5,757,263	05/26/98	Ravindranathan			01/22/97
	S	5,764,129	06/09/98	Syouji, et al.			03/25/96
	T	5,790,011	08/04/98	Hirano, et al.			06/28/96
	U	6,180,291	01/30/01	Bessy, et al.			01/22/99

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Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No

### Other Documents

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